

68/1762

PATENT APPLICATION

#4
5-5-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Attorney Docket No.: 44046.203.143.21

Hartig, et al.

Application No.: 09/728,435

Examiner: Unknown

Filed: December 1, 2000

Group Art Unit: 1762

For: HAZE-RESISTANT TRANSPARENT FILM STACKS

SUPPLEMENTAL
INFORMATION DISCLOSURE STATEMENT

COPY OF PAPERS
ORIGINALLY FILED

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

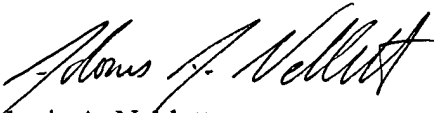
This information is being filed before the mailing date of a first Office Action on the merits. No certification or fee is required.

I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, or to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(2).

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The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,


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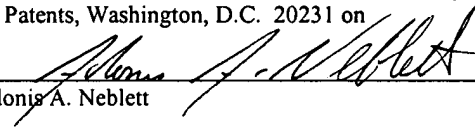
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